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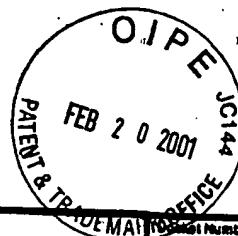
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Technology Center 2100/SB/08 (11-90)

Sheet 1 of 2

F m PTO-1449



INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

E MAIL ADDRESS (Optional)

Application Number

1100

09/644,390

1

REINHOLD BERBERICH

Filing Date AUGUST 22, 2000

Group Art Unit 2,747

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	19809624	5/27/99	GERMANY				
	4409167	6/29/95	GERMANY				
	4021136	1/17/91	GERMANY				
PP	2332548	6/23/99	GREAT BRITAIN				
	9936295	7/22/99	WO PCT				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		SEARCHED	INDEXED	FILED	SEARCHED	INDEXED	FILED

EXAMINE

P. S. D. K.

DATE CONSIDERED

02 | 13) 2004

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